



Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce U. S. PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109121	APPLICATION NO. 09/819,687	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Eiji NATORI		
				FILING DATE March 29, 2001	GROUP 2822	
U. S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
MG		5,753,320	5/1998	Mikoshiba et al.		
MG		5,803,974	9/1998	Mikoshiba et al.		
MC		4,668,337	9/1987	Sekine et al.		
MC		5,527,731	6/1996	Yamamoto et al.		
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
MC		Shimizu, Masaru; "Effects of O ₃ on Growth and Electrical Properties of Pb(Zr, Ti)O ₃ Thin Films by Photoenhanced Metalorganic Chemical Vapor Deposition; Department of Electronics, Kyoto University; September, 1994; pp. 5135-5138.				
EXAMINER <i>Maria Guerero</i>		DATE CONSIDERED <i>6-30-03</i>				
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						